



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :  
Yoshimi SATO et al. :  
Serial No. 10/665,143 : **Attn: APPLICATION BRANCH**  
Filed September 22, 2003 : Attorney Docket No. 2003\_1356

COATING SOLUTIONS FOR USE IN  
FORMING BISMUTH-BASED  
FERROELECTRIC THIN FILMS AND  
A METHOD OF FORMING BISMUTH-  
BASED FERROELECTRIC THIN FILMS  
USING THE COATING SOLUTIONS : **Confirmation No. 5804**

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**PRELIMINARY AMENDMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the Official Action dated March 18, 2003 in the parent application, please amend the present application as follows: